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B/O Form PTO-1449	Att. Docket Number JEK/BEU/OLAFSSON	Serial Number 09/670,028
U.S. Department of Commerce Patent and Trademark Office	Applicant Steinunn OLAFSSON	
Information Disclosure Statement by APRIL 1, 2002	Filing Date September 26, 2000	Group 1762

U.S. Patent Documents

Examiner Initial	Document Number	Date	Patentee/Applicant	Class	Subclass	Filing Date if Appropriate
	4566937	1/86	Pitts			
	5534311	7/96	Shaw et al			
	6261421	7/01	Meunier et al			
	5509843	4/96	Akama			
	5352330	10/94	Wallace			
	5015323	5/91	Gallagher			
	5038322	8/91	Van Loenen			
	4343993	8/82	Binnig et al			
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	4896044	1/90	Li et al			
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Foreign Patent Documents

Examiner Initial	Document Number	Publication Date	Country/Agency	Class	Subclass	Translation	
						Yes	No

Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

Examiner	<i>Sharonne K.P. Goto</i>	Date Considered	<i>9/16/02</i>
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B/O Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant		Atty. Docket Number JEK/BEU/OLAFSSON	Serial Number 09/670,028
		Applicant Sveinn OLAFSSON	
		Filing Date September 26, 2000	OIGUE DEC 05 2000 1762

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MP	Marchand, H., et al., <u>Structural and optical properties of GaN laterally overgrown on Si(111) by metalorganic chemical vapor deposition using an AlN buffer layer</u> , pp. 1-10, MRS Internet J. Nitride Semicond. Res. 4, 2 (1999). (<u>no month given, but after March 10th</u>)
MP	Van der Stricht, W., et al., <u>Study of GaN films grown by metalorganic chemical vapour deposition</u> , pp. 1-6, MRS Internet J. Nitride Semicond. Res. Vol. 1, Art. 3 (1996). (<u>month not given, but after Aug 5th</u>)
MP	Marchand, H., et al., <u>Fast Lateral Epitaxial Overgrowth of Gallium Nitride by Metalorganic Chemical Vapor Deposition Using a Two-Step Process</u> , pp. 1-6, MRS Internet J. Nitride Semicond. Res. 4S1, G4.5 (1999). <u>no month</u>
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Examiner <i>Mark Padgett</i>	Date Considered <i>9/16/02</i>
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